

U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. 6063/USA/CM1/WCVD/LE	Serial No. 107055634
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT <i>FEB 26 2002</i>		Applicant Yudovsky, et al.	Confirmation No.: 100
(Use several sheets if necessary)		Filing Date January 22, 2002	Group Not yet assigned
Examiner <i>TRADEMARK</i> Not yet assigned			

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
<i>PL</i>	A1	5,155,652	10-13-92	Logan, et al.	361	234	05-02-91
<i>PL</i>	A2	5,275,683	01-04-94	Arami, et al.	156	345	10-23-92
<i>PL</i>	A3	5,280,156	01-18-94	Niori, et al.	219	385	12-23-91
<i>PL</i>	A4	5,350,720	09-27-94	Kawada, et al.	501	97	04-12-93
<i>PL</i>	A5	5,383,971	01-24-95	Selbrede	118	728	03-11-92
<i>PL</i>	A6	5,462,603	10-31-95	Murakami	118	719	06-24-94
<i>PL</i>	A7	5,476,548	12-19-95	Lei, et al.	118	728	06-20-94
<i>PL</i>	A8	5,581,874	12-10-96	Aoki, et al.	29	825	03-27-95
<i>PL</i>	A9	5,643,483	07-01-97	Kubota, et al.	219	543	03-08-95
<i>PL</i>	A10	5,665,260	09-09-97	Kawada, et al.	219	464	12-27-94
<i>PL</i>	A11	5,676,758	10-14-97	Hasegawa, et al.	118	173E	04-22-96
<i>PL</i>	A12	5,766,363	06-16-98	Mizuno, et al.	118	725	04-19-96
<i>PL</i>	A13	5,796,074	08-18-98	Edelstein, et al.	219	390	11-28-95

Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
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	B2						<input type="checkbox"/>	<input type="checkbox"/>
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	B5						<input type="checkbox"/>	<input type="checkbox"/>

OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
<i>PL</i>	C1	Lei, et al. "Ceramic Substrate Support", U.S. Patent Application Serial No. 09/596,854, filed June 19, 2000
	C2	
	C3	

Examiner _____ Date Considered _____

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)				Docket No. 6063/USA/CM/WCVD/LE	Serial No. 10/055,634
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT <i>FEB 26 2002</i>				Applicant Yudovsky, et al.	Confirmation No.: 100
Use several sheets if necessary)				Filing Date January 22, 2002	Group Not yet assigned
EXAMINER & TRADEMARKS		Examiner Not yet assigned			

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*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
Re	A14	5,721,062	02-24-98	Kobayashi	428	688	06-07-95
Re	A15	5,854,468	12-29-98	Muka	219	443	01-25-96
Re	A16	5,882,419	03-16-99	Sinha, et al.	118	729	09-29-97
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Re	A20	6,189,482 B1	02-20-01	Zhao, et al.	118	723R	02-12-97
Re	A21	6,267,839 B1	07-31-01	Shamouilian, et al.	156	345	01-12-99
	A22						
	A23						
	A24						
	A25						
	A26						

Foreign Patent Documents

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	B4						<input type="checkbox"/>	<input type="checkbox"/>
	B5						<input type="checkbox"/>	<input type="checkbox"/>

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INFORMATION DISCLOSURE STATEMENT
(Use several sheets if necessary)APPLICANT
Yudovsky, et al.FILING DATE
HerewithGROUP
Not yet assigned

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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
Re		5,242,501	09-07-93	McDiarmid	118	728	
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Re		5,505,779	04-09-96	Mizuno, et al.	118	719	
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Re		6,223,447	05-01-01	Yudovsky, et al.	34	58	

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	Re	Yudovsky, et al. "Self Aligning Non Contact Shadow Ring Process Kit" U.S. Patent Application No. 09/459,313 filed December 10, 1999
	Re	Shamouillian, et al. "Multi-Layer Ceramic Electrostatic Chuck with Integrated Channel" U.S. Patent Application No. 09/149,807 filed September 8, 1998

EXAMINER

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